



In re application of

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Hidenao SUZUKI et al.

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ELECTROLYTIC PROCESSING APPARATUS
AND SUBSTRATE PROCESSING APPARATUS

CLAIM OF PRIORITY UNDER 35 USC 119

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants in the above-entitled application hereby claim the date of priority under the International Convention of Japanese Patent Application No. 2003-25159, filed January 31, 2003, and Japanese Patent Application No. 2003-384322, filed November 13, 2003, as acknowledged in the Declaration of this application.

Certified copies of said Japanese Patent Applications are submitted herewith.

Respectfully submitted,

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